Notice of Allowability	Application No.	Applicant(s)
	10/642,267	PALFY ET AL.
	Examiner	Art Unit
	Chen-Wen Jiang	3744
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap or other appropriate communication GHTS. This application is subject to GHTS.	pplication. If not included n will be mailed in due course, THIS
1. This communication is responsive to amendment and TD fi	iled on 7/12/2004.	•
2. The allowed claim(s) is/are <u>1,8,10-16,25,27-34,36,37 and 5</u>	<u>54-90</u> .	
3. The drawings filed on 18 August 2003 are accepted by the	Examiner.	
 4.	been received. been received in Application No cuments have been received in this of this communication to file a reply ENT of this application. itted. Note the attached EXAMINER es reason(s) why the oath or declarate t be submitted. on's Patent Drawing Review (PTO Amendment / Comment or in the Comment or in the Comment of the drawing he header according to 37 CFR 1.121(sit of BIOLOGICAL MATERIAL)	complying with the requirements R'S AMENDMENT or NOTICE OF ation is deficient. -948) attached Office action of the back) of (d). must be submitted. Note the
 Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☒ Information Disclosure Statements (PTO-1449 or PTO/SB/06 Paper No./Mail Date 20031118,20040504 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material 	6. Interview Summary Paper No./Mail Da 8), 7. Examiner's Amende	te

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REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance: Claims 1,8,10-16,25,27-34,36,37 and 54-90 have been allowed because prior art of record fails to disclose or suggest a device that determines condensation comprising, in combination, a first thermal sensor in thermally conductive contact with the surface; a second thermal sensor in an environment separated from the surface; a humidity sensor in the environment of the second thermal sensor, a condensation suppression mechanism; and a circuit; wherein the second thermal sensor is positioned at a sufficient distance from the surface such that a space between the surface and the second thermal sensor precludes thermal transfer between the surface and the second thermal sensor.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Chen-Wen Jiang whose telephone number is (703) 308-0275 (571 272-4809 after 11/20/2004). The examiner can normally be reached on Tuesday-Friday from 7:00 to 5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Denise Esquivel can be reached on (703) 308-2597. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Chen-Wen Jiang Primary Examiner